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Keith Doyle has over 25 years of experience in the field of optomechanical engineering, working on a diverse range of high-performance optical instruments specializing in the multidisciplinary analysis and integrated modeling of optical systems. He is currently a Group Leader in the Engineering Division at MIT Lincoln Laboratory. He previously served in a variety of roles including Vice President of Sigmadyne, Inc., Senior Systems Engineer at Optical Research Associates, and a Structures Engineer at Itek Optical Systems. He received his Ph.D. from the University of Arizona in Engineering Mechanics with a minor in the Optical Sciences in 1993, and he holds a BS degree from Swarthmore College received in 1988. Dr. Doyle is an active participant in SPIE symposia, teaches short courses on optomechanics and integrated modeling, and has authored and co-authored over 30 technical papers in optomechanical engineering.



Dr. Victor Genberg PE has over 45 years of experience in the application of finite element methods to high-performance optical structures, and is a recognized expert in optomechanics. He is currently President of Sigmadyne, Inc. Prior to starting Sigmadyne, Dr. Genberg worked at Eastman Kodak for 28 years, serving as a technical specialist for commercial and military optical instruments. He is an author of SigFit, a commercially available

software product for optomechanical analysis. Dr. Genberg is also a full professor (adjunct) of Mechanical Engineering at the University of Rochester, where he teaches a variety of courses in finite elements, design, optimization, and optomechanics. He has over 50 publications. He received his Ph.D. from Case Western Reserve University in 1973.



Gregory Michels PE has worked for twenty years in optomechanical design and analysis, and is currently Vice President of Sigmadyne, Inc. He received his MS degree in Mechanical Engineering from the University of Rochester in 1994. He specializes in finite element analysis and design optimization of high-performance optical systems. Mr. Michels is also a software developer and technical support engineer for Sigmadyne's optomechanical analysis

software product, SigFit. Prior to co-founding Sigmadyne, he worked at Eastman Kodak for five years as a structural analyst on the Chandra X-Ray Observatory. Mr. Michels has authored or co-authored over 25 papers in the field of integrated optomechanical analysis and teaches short courses on finite element analysis and integrated modeling.